



Indian Institute of Science Education and Research Bhopal

Department of Electrical Engineering and Computer Science

Date: February 21, 2025

Applications are invited from the interested candidates for the post of JRF to work on the R&D project titled "Design and development of Oven-controlled MEMS (Microelectromechanical Systems) Resonator" supported by Indian Space Research Organisation (ISRO), Govt. of India under RESPOND scheme. We are looking for a candidate interested in the area of **MEMS, microfabrication, system design, sensors and systems, sensor fabrication, sensor integration, etc.**

Number of posts: 01 (One)

Duration: 6 months initially (extendable to two years maximum).

Salary: The salary will be as per project norms.

Minimum qualifications: Post Graduate Degree (BS-MS/ MS/ M.Tech./ M.Sc. or equivalent) in Professional Course in the area of Electrical Engineering, Electronics Engineering, Physics with Electronics Specialization, Electrical Engineering, Electronics Engineering, or relevant field from a recognized university or an Institute. At least one year research experience in fabrication or characterization of micro or nano scale device and materials is mandatory.

How to apply: Fill in the form using the following link.

Link:

<https://docs.google.com/forms/d/e/1FAIpQLSce9hnXi8vtfGxON2suCu8JIEHmZ5MjD9APuyqltUKr5EbpWQ/viewform?usp=sharing>

No other correspondence related to the status of your application will be entertained. Shortlisted candidates will be invited for an online/offline interview with the selection committee. No TA/DA will be given.

Last date to apply: 7th March 2025.

Note: Applications shall be considered till a suitable candidate is found and the position is filled. Interviews for the shortlisted candidates will be conducted on or after 8th March 2025.

For any queries regarding this position, please contact

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